

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: )  
 )  
Satoshi Murakami, et al. )  
 )  
Serial No: 09/516,082 )  
 )  
Filed: March 1, 2000 )  
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Art Unit: 2815 )  
 )  
Confirmation No.: 3545 )  
 )  
Examiner: Eugene Lee )  
 )  
For: Semiconductor Device Comprising A )  
Thin Film Transistor Comprising A )  
Semiconductor Thin Film And Method )  
Of Manufacturing The Same )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**SUPPLEMENTAL AMENDMENT P (AFTER ALLOWANCE)**

Dear Sir:

In furtherance of Amendment O (After Allowance) filed on November 10, 2009 with an RCE, please amend the above-identified application as follows: